10/637108 Examiner: LEBENTRITT, MICHAEL GAU: 2824

Classification: 438/685.000 Inventor: SANDHU, GURTEJ, et al Status: 80 - RESPONSE AFTER FINAL ACTION FORWARDED TO EXAMINER

Title: LOW-RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHO...

Bib Data report

Application Title:LOW-RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHOUS TITANIUM CARBONITRIDE BARRIER LAYER

Application Num: (in phx) <u>10637108</u> **Filing Date:**08/08/2003

Effective Filing 08/08/2003

(Location History) (Foreign/Continuity Data)

Status: 80/RESPONSE AFTER FINAL ACTION FORWARDED TO EXAMINER

Status Date: 08/10/2004

Patent Number: Not Issued Issue Date: N/A Date of Abandonment: N/A

Confirmation Number:5025 **PALM Location:**

Examiner: 73858 LEBENTRITT, MICHAEL Assignment Data) Group Art

Unit: 2824 Class/Subclass: 438/685.000

State or Country:IDAHO Sheets/Drawing: 4 Total Claims: 20

Independent Claims:2

Inventors:

Last name, First name: City: Country or State:

SANDHU, GURTEJ BOISE IDAHO

DOAN, TRUNG BOISE IDAHO

LOWREY, TYLER BOISE IDAHO

Attorneys: ALL Attorney Docket No:3264.6US (92-0280.09/US)

Interference No: Lost Case: No Unmatched Petition: No L&R Code:1

Application Number		ANDHU ET AL.
TERMINAL DISCLAIMER		☐ DISAPPROVED
Document Code - DISQ	This patent is subject to a Terminal	
INTERNAL DOCUMENT - DO NOT MAIL	Disclaimer	

U.S. Patent and Trademark Office